## **EXPEDITED PROCEDURE - GROUP ART UNIT 2619** RESPONSE UNDER 37 C.F.R. §1.116

U.S. Serial No. 10/821,016

Response to Final Office Action dated April 15, 2009

Patent/Docket No. 2003-0372 / 24061.93 Customer No. 42717

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hsiao-Wen Wan, et al.

Docket No.:

24061.93 / 2003-0372

Serial No.:

10/821,016

Examiner:

Peling A. Shaw

April 8, 2004

Art Unit:

Filed:

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2444

For:

Method for Circulating a Report in §

Conf. No.:

9310

a Semiconductor Manufacturing

Environment

## RESPONSE TO FINAL OFFICE ACTION DATED APRIL 15, 2009

Mail Stop: AF Commissioner For Patents PO Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This paper is submitted in response to the Office action dated April 15, 2009, in connection with the above-noted application. No fees, including extension of time fees, are believed necessary for consideration of the present paper. However, if any fees, including extension of time fees, are necessary, the extension of time is hereby requested, and the Commissioner is hereby authorized to charge any fees, including those for the extension of time, to Haynes and Boone, LLP's Deposit Account No. 08-1394

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.